

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:	)	Group Art Unit:
	)	
Junichi SATO et al.	)	Examiner:
	)	
Application No.:	)	
	)	
Filed:	)	
	)	
For: SEMICONDUCTOR THIN FILM	)	
AND METHOD OF FABRICATING	)	
SEMICONDUCTOR THIN FILM,	)	
APPARATUS FOR FABRICATING	)	
SINGLE CRYSTAL	)	
SEMICONDUCTOR THIN FILM,	)	
AND METHOD OF FABRICATING	)	
SINGLE CRYSTAL THIN FILM,	)	
SINGLE CRYSTAL THIN FILM	)	
SUBSTRATE, AND	)	
SEMICONDUCTOR DEVICE	)	

Mail Stop Patent Application  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**PRELIMINARY AMENDMENT PURSUANT TO 37 C.F.R. § 1.53(b)**

Dear Sir:

The above-identified application is a divisional of Application No. 09/946,898 filed September 5, 2001. Please amend the instant application as follows.